

WEST**Freeform Search****Database:**

US Patents Full-Text Database
US Pre-Grant Publication Full-Text Database
JPO Abstracts Database
EPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins

Term:

17 and robot same position

Display:

10

Documents in Display Format:

CIT

Starting with Number

1

Generate: Hit List Hit Count Image**Search History****Today's Date:** 6/28/2001

<u>DB Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	17 and robot same position	11	<u>L8</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	16 and position same rail	105	<u>L7</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	15 and position adj (sensor or detector)	142	<u>L6</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	14 and processing	1141	<u>L5</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	12 and guide adj rail	2980	<u>L4</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	11 and guide adj rail	0	<u>L3</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	wafer or substrate	1481110	<u>L2</u>
USPT,PGPB,JPAB,EPAB,DWPI,TDBD	WO 9819333	2	<u>L1</u>